

# Antistatic PEEK Vacuum Tips

High Performance Press-Fit Molded Vacuum Wand Tips

## Press-fit Vacuum Tip Options

Straight  
 Extended Length  
 Bent 10 degrees down  
 Bent 10 degrees up  
 Bent 20 degrees down  
 Bent 20 degrees up  
 Bent 30 degrees down  
 Bent 30 degrees up  
 Bent 20 degrees right  
 Bent 20 degrees left  
 With limit stops

Contamination Color Coded



**T691PKAS**  
50mm-100mm wafer handling



**T692PKAS**  
75mm-150mm wafer handling



**T694PKAS**  
75mm-150mm wafer handling



**T693PKAS3**  
100mm-200mm wafer handling



**T695PKAS**  
150mm-200mm heavy substrate wafer handling



**T791PKAS**  
50mm-75mm thin/fragile wafer handling



**T792PKAS**  
75mm-125mm thin/fragile wafer handling



**T794PKAS**  
75mm-150mm thin/fragile wafer handling



**T693PKAS3-001**  
100mm-200mm thin/fragile wafer handling



**T696PK**  
100mm-200mm with UHMW pocket polished wafer handling



### Typical antistatic vacuum wand assembly:

- NOASPF2 (normally open wand handle)
- CC11SDS (vacuum coil cord)
- HSU (shut off holder table/wall mount)
- T693PKAS3 (vacuum tip)

© 2010 H-Square Corp

**H-SQUARE**  
CORPORATION

2991 Copper Road  
Santa Clara, CA 95051 USA

T (408) 732-1240  
F (408) 732-7970  
www.h-square.com  
info@h-square.com

## ナガセテクノエンジニアリング株式会社

◇横浜市港北区新羽町 887 TEL 045-541-0208 FAX 045-541-0237  
 ◇熊本市東区石原 1-11-70 TEL 096-389-7865 FAX 096-389-7869